Next Step Plans

In HP Carbon, as you have your allocated plans, you can select one of them and create next step plans for it. Single next step plan is the stage of polishing of the stone. The stage is related to the specific facet type; it contains the sequence of steps. Each step plan is the stage of polishing of the stone. The stage is related to the specific facet type; it contains the sequence of steps. initial (before polishing) and final (after polishing) states.



1 Creating Next Step Plans 2 Next Step Plan Parameters

Creating Next Step Plans

To create a new next step plan:

- 1. In the Recut mode, select the target plan.
- 2. Switch to the G1 Galahad mode.

You can also initiate creating next step plan right in the Recut mode. To do that, in the Recut mode, right-click your target plan, then from the context menu select Galahad: Generate Next Step Plans.... The Next Step Plans panel will be displayed.



- 3. Click Generate next faceting stage. The Next Step Plans panel is displayed.
- 4. Select Facet type from the list.
- 5. Set next step plan parameters.
- 6. Click Generate Next Step Plans. The stage is created and populated with steps.



Next Step Plan Parameters

| Parameter | | Example | Description |
|---------------------------|---|--|---|
| Facet type | Next Step Plans × Facet type: Crown Main First facet azimuth: 45.2° Setting facets sequence: Consecutive Processing direction Azimuth increase: Pavilion (CCW), Crown (CW) Azimuth decrease: Pavilion (CW), Crown (CCW) Allowance Angle: 0.10° Depth: 5µm Setter Next Step Plans | Table Crown Main Crown Star Girdle Pavilion Main Pavilion Half Culet 8.4° 37.1° 55.3° 82.9° 99.6° 128.6° 146.0° 172.1° 188.9° 218.6° 236.4° 261.1° 278.9° 308.1° 325.9° 350.6° | Set of the facet types presented in the list depends on the cutting type and the current Facet I Select the facet type from the list to generate a next step plan (stage) that will include all the s Note The value may also be selected by clicking any facet of the required type in the scene. The parameter lists the azimuths of the presented facets of the type, defined by Facet type. The selected value defines the facet which will be polished on the first step. The value may be |
| Setting facet sequence | | Crosswise Through one Consecutive | Together with Processing direction , defines in which order the facets will be polished startin • "Consecutive" - the facets will be polished consecutively. • "Through one" - every second facet will be skipped within the first circle and covered cor • "Crosswire" - the facets will be polished crosswire, the ones outside the first cross will be |
| Processing direction | | Processing direction Azimuth increase: Pavilion (CCW), Crown (CW) Azimuth decrease: Pavilion (CW), Crown (CCW) | Together with Setting facet sequence, defines in which order the facets will be polished star Azimuth increase: Pavilion (CCW), Crown (CW) Azimuth decrease: Pavilion (CW), Crown (CCW) |
| Allowance | | Allowance Angle: 2.00° Depth: 30µm | Defines whether facets should be polished up to the brilliant (0.00° and 0.00µm) or with some You can set allowance for the depth in µm or for the angle in ° or combine these two allowance Setting allowance for the next step plan allows polishing the same facet types within several of facets with the allowance of 10µm for the depth on one stage, and then finalize polishing thes Notes • Normal allowance change from stage to stage is decreasing down to 0, for example: 30 • Default value is: 0.00° and 0.00µm |

acet Marking.

the steps related to the facets of the selected type.

ay be selected from the list or by clicking the required facet in the scene.

tarting from the one defined by First facet azimuth:

ed consecutively within the second. will be covered within the following

starting from the one defined by First facet azimuth:

ome allowance.

vances.

eral different next step plans (stages). For example, you can polish Crown Main these facets in a later stage up to the end (0.00µm allowance).

 $: 30 > 15 > 10 > 0 \mu m \text{ or } 3^{\circ} > 1^{\circ} > 0^{\circ}$